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IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

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) Art Unit (not assigned)
Application No.: (not assigned))
)
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)
For: VACUUM EVAPORATION DEPOSITION)
METHOD OF THE WINDING TYPE AND)
VACUUM EVAPORATION DEPOSITION)
APPARATUS OF THE SAME)

Pittsburgh, Pennsylvania

PRELIMINARY AMENDMENT

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Sir:

Kindly enter the following preliminary amendments to the claims, specification, abstract and drawings as indicated hereinafter.